

Docket No.: 8733.713.10-US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Han-Wook Hwang

Customer No.: 30827

Application No.: 10/733,237

Confirmation No.: TBA

Filed: December 12, 2003

Art Unit: N/A

For:

POLY-CRYSTALLINE THIN FILM

TRANSISTOR AND FABRICATION

METHOD THEREOF

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed within three months of the U.S. filing . date (37 CFR 1.97(b)(1)).

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0911, under Order No. 8733.713.10-US. A duplicate copy of this paper is enclosed.

Dated: March 15, 2004

Respectfully submitted,

Rebecca Goldman Rudich Registration No.: 41,786

MCKENNA LONG & ALDRIDGE LLP

1900 K Street, N.W. Washington, DC 20006

(202) 496-7500

Attorneys for Applicant

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Attorneys for Applicant

PTO/SB/08A (10-01)

Approved for use through 10/31/2002.OMB 0651-0031

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Sut	Substitute for form 1449A/PTO			Complete if Known		
002				Application Number	10/733,237	
INFORMATION DISCLOSURE				Filing Date	December 12, 2003	
STATEMENT BY APPLICANT			PPLICANT	First Named Inventor	Han-Wook Hwang	
	(use as many sheets as necessary)			Art Unit	ТВА	
				Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	8733.713.10-US	

U.S. PATENT DOCUMENTS						
Examiner	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
Initials*		Number-Kind Code ² (if known)				
	AA	5,953,598	9/14/1999	Hata et al.		
	AB	5,898,188	4/27/1999	Koyama et al.		
	AC	5,648,277	7/15/1997	Zhang et al.		
	AD	5,835,172	11/10/1998	Yeo et al.		
	AE	6,569,717 B1	5/27/2003	Murade		
	AF					
	AG					

	FOREIGN PATENT DOCUMENTS							
Examiner	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or	Pages, Columns, Lines, Where Relevant ent Passages or Relevant Figures Appear			
Initials*		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)		Applicant of Cited Document		T⁵		
	BA							
7.50	BB							
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¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS					
Examiner Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
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